Fast thermal relaxation in cavity-coupled graphene bolometers with a Johnson noise read-out


High sensitivity, fast response time and strong light absorption are the most important metrics for infrared sensing and imaging. The trade-off between these characteristics remains the primary challenge in bolometry. Graphene with its unique combination of a record small electronic heat capacity and a weak electron–phonon coupling has emerged as a sensitive bolometric medium that allows for high intrinsic bandwidths. Moreover, the material’s light absorption can be enhanced to near unity by integration into photonic structures. Here, we introduce an integrated hot-electron bolometer based on Johnson noise readout of electrons in ultra-clean hexagonal-boron-nitride-encapsulated graphene, which is critically coupled to incident radiation through a photonic nanocavity with Q ~ 900. The device operates at telecom wavelengths and shows an enhanced bolometric response at charge neutrality. At 5 K, we obtain a noise equivalent power of about 10 pW Hz−1/2, a record fast thermal relaxation time, <35 ps, and an improved light absorption. However the device can operate even above 300 K with reduced sensitivity. We work out the performance mechanisms and limits of the graphene bolometer and give important insights towards the potential development of practical applications.

Since the invention of the bolometer, its main design principles have relied on efficient light absorption into a low-heat-capacity material and its exceptional thermal isolation from the environment. Though reduced thermal coupling to its surroundings allows for an enhanced thermal response, it in turn strongly increases the thermal time constant and dramatically lowers the detector’s bandwidth. Due to its record-low electronic heat capacity C_e (refs 1,4,5) and weak heat dissipation and absorbed radiation can give rise to an electron temperature, T_e, that can be dramatically higher than the lattice temperature, T_L, while maintaining a fast thermal relaxation time (Fig. 1a). These unique thermal properties and its broadband photon absorption from the UV to GHz frequencies make graphene a promising platform for ultrasensitive and ultrafast hot electron bolometers, calorimeters and single-photon detectors for low-energy photons.

Previous studies have demonstrated graphene’s potential as a sensitive bolometer; however, many challenges remain for real applications. Most experiments utilized graphene on a SiO_2 substrate with a slow d.c. transport readout. To achieve a high response, graphene’s weak temperature-dependent resistance ΔR(T)/ΔT had to be artificially increased by introducing disorder; patterning nanostructures or opening a bandgap in bilayer graphene. As disorder introduces charge fluctuations at the charge neutrality point (CNP), it limits the detector’s response, as the lowest C_e values in close vicinity to the CNP cannot be reached. Low light absorption of only ~2.3% (below THz wavelengths) makes these devices more impractical.

It was recently shown that it is possible to use a universal T_e readout utilizing microwave frequency Johnson noise (JN), which is emitted by thermally agitated electrons in graphene (refs 1,4,5). This direct T_e readout scheme does not require a large ΔR(T)/ΔT, and allows use of ultraclean hexagonal boron nitride (hBN) encapsulated graphene devices without sacrificing the detector’s sensitivity. In state-of-the-art devices the carrier density can be tuned to reach ultrasmall values of n < 10^{10} cm−2 (ref. 1) where C_e can reach record low values of just one Boltzmann constant k_B. Moreover, recent progress in the critical coupling of graphene to resonant photonic cavities and to antennas showed that one can achieve close to unity light absorption into graphene for a broad range of frequencies.

In this manuscript we combine all of the above techniques in a proof-of-concept device. Figure 1b shows the schematics and the operation principle of the bolometer. A high-quality hBN–G–hBN graphene heterostructure is integrated onto a suspended silicon photonic crystal cavity (PCC), with a linear three-hole (L3) defect, which serves to form confined optical cavity modes. The resonant cavity mode of the PCC (Fig. 1c) is critically coupled to the telecom spectrum and evanescently overlaps with the graphene sheet. To maximize heat generation and to minimize heat dissipation, the graphene stack is etched into a circle with 5 μm diameter, which corresponds to the expected length scale over which the electron temperature relaxes back to thermal equilibrium. It is further connected to gold leads with narrow, resistive graphene channels. To effectively transmit the microwave Johnson noise signal through the circuit, the high resistance of the graphene (R ~ 20 kΩ) is impedance matched to the microwave transmission line (50 Ω) by the addition of a carefully chosen inductor and capacitor. The so formed resonant RLC circuit has a resonance frequency of ~70 MHz with a bandwidth of ~6 MHz, and allows transmission of most of the JN power (JNP) (see Supplementary Information) to a low-noise amplifier (LNA) and a heterodyne circuit, which are situated at room temperature. The radio frequency circuit forms the JN readout scheme, and its voltage output is directly proportional to the emitted JNP.

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By applying a gate voltage $\Delta V_{bg}$ (referenced to the CNP) to the PCC one can control the carrier density of the graphene sheet.

The device is probed at $T_e = 5\, \text{K}$ and $\Delta V_{bg} = 0\, \text{V}$ with linearly polarized excitation pulses from a tunable near-infrared laser, which are normally incident onto the device through a cross-polarized confocal scanning set-up\(^1\) (Supplementary Information). Simultaneously to spatial scanning of the laser, the calibrated JNP is read out\(^1\). As the JNP is directly proportional to $T_e$ (Supplementary Information), we are able to obtain the electronic temperature increase due to laser excitation $\Delta T_e$ for each laser spot position. Figure 1d shows the optical image of the device and Fig. 1e the $\Delta T_e$ spatial map for 0° and 90° polarized light at the PCCs resonant frequency of 1,532 nm and an incident power of $P_{\text{in}} = 5.4\, \mu\text{W}$. Here, a sizeable $\Delta T_e$ increase is generated only when the laser is incident directly onto the graphene, confirming that the JN readout is only sensitive to thermal noise inside the graphene channel. As the PCC's resonant mode only couples to light with polarization along the $x$-axis, one can compare the response off (90° polarization) and on (0° polarization) resonance (Fig. 1c, left and middle). When off resonance, $\Delta T_e$ is roughly constant over the entire graphene region, assuming that 2.3% of the incident light is homogeneously absorbed in the whole graphene region. Whereas when on resonance, in addition to direct light absorption, light is also resonantly coupled into the PCC. The resonant mode interacts with graphene and gives a strong rise to an enhancement of $\Delta T_e$ in the cavity region. With the thermal model presented in Fig. 1a (Supplementary Information), the theoretically expected $\Delta T_e$ map is calculated (Fig. 1e right), and shows very good agreement with experimental findings.

To characterize the enhancement of light absorption by the PCC we perform measurements of the reflection spectrum of the irradiated cavity before the deposition of the hBN–G–hBN stack and after. Figure 2a shows the fundamental mode of the pure cavity with a resonance mode at 1,512.8 nm and a quality factor of $Q \approx 7,000$. After the hBN–G–hBN deposition, the cavity resonance is red-shifted to 1,531.7 nm and its $Q$ drops to ~900. Here the shift of the mode is mainly due to hBN's high dielectric constant of ~3.9, while its broadening is caused by the light absorption in graphene. From coupled mode theory\(^18\), we estimate that the total absorption of the cavity resonant field into graphene is ~45%.

Overall the enhanced light absorption strongly amplifies the photoresponse. Figure 2b shows $\Delta T_e$ as a function of incident laser wavelength for 0° (on) and 90° (off) polarized light with respect to the cavity $x$-axis (Fig. 1c). In the on state at a resonance wavelength of 1,531.7 nm, $\Delta T_e$ is enhanced by a factor of ~3 and follows a sinusoidal dependence as a function of the polarization angle (Fig. 2b inset). From the difference of the $\Delta T_e$ increase on and off resonance, we can deduce that the total absorption in graphene is enhanced from 2.3% to more than 7%. Since graphene absorbs ~45% of the cavity field, we extract a coupling efficiency of the cavity field to normal incidence laser light to be ~10%, consistent with simulation results. With improved fabrication, however, one can expect near-unity absorption through critical coupling to a waveguide\(^{12,21}\) or free-space\(^{24,25}\), and experimentally $>90\%$ absorption from a photonic nanocavity into graphene has already been demonstrated\(^19\).

We now probe $\Delta T_e$ as a function of absorbed laser power $P$ (assuming 7% incident light absorption) at $T_e = 5\, \text{K}$ and a measurement time of $t_m = 1\, \text{s}$ (Fig. 3a). Here the $\Delta T_e(P)$ dependence
transitions from a linear to a sublinear dependence with increased $P$, and is overall strongly reduced at elevated temperatures (inset Fig. 3a). We can model this behaviour with the two-dimensional heat transfer equation below (equation (1)), which takes into account the two main mechanisms: electronic dissipation through the Wiedemann–Franz (WF) law (first term) and through electron–phonon (e–ph) interactions (second term):

$$\hat{q} = -\nabla \cdot [\kappa \nabla T_e] + \Sigma_{ph} [T_e^3 - T_s^3],$$

where $\Sigma_{ph}$ is the e–ph coupling strength, $\kappa = (\pi k_B T_e)/3\rho$ the thermal conductivity and $\rho$ the device resistivity, which is extracted from transport measurements (Supplementary Information). Numerical modelling with only one fitting parameter $\Sigma_{ph} = 0.038$ W m$^{-2}$ K$^{-3}$ produces a good match with the experiment and agrees well with previously reported values. We can qualitatively understand the sub-linear behaviour by the overall enhancement of the electronic thermal conductivity $G_e$ at higher $T_e$, where both WF and e–ph dissipation channels are strongly enhanced. The bolometric response due to laser heating is furthermore consistent with the response through Joule heating of the sample with a large current (Fig. 3a).

Here minor deviations can be attributed to saturable light absorption in graphene at higher laser powers.

Ultimately, the bolometric response is limited by the electronic thermal conductivity, $G_e$, through the simple relation $\Delta T_e = P/G_e$, which is a direct consequence of equation (1). From measurements at various $T_e$ with a fixed $P = 100$ nW, we obtain the $G_e(T_e)$ dependence (Fig. 3b). It is in good agreement with the heat dissipation model, and follows a linear WF dependence at low $T_e$ and a power law e–ph dependence at higher $T_e$. Since both $C_e$ and $G_e$ are expected to be strongly reduced at the CNP, we test $\Delta T_e$ as a function of gate voltage $\Delta V_{bg}$, Figure 3c plots $\Delta T_e(\Delta V_{bg})$ for $P = 10$ nW and compares it to $R(\Delta V_{bg})$ (both taken at $T_e = 5$ K). The response sharply increases by a factor ~3 at the CNP and qualitatively follows the same dependence as $R(\Delta V_{bg})$. However, the enhancement of the response at the CNP is predicted to be several orders of magnitude higher at mK temperatures, as thermal broadening of the Fermi energy is reduced and $C_e$ is dramatically lowered.

In analogy to previous work on graphene pn-junctions, we can now test the thermal relaxation time of the hot electrons, $\tau$, which defines the intrinsic bandwidth limit of the detector. $\tau$ can be probed by the excitation of the bolometer with two $t_d$ time-delayed pulses (Supplementary Information), where the first pulse heats the electrons to an elevated $T_e$, and the second pulse heats the electron gas further. For $t_d$ ~0 ps, the $T_e$ rise due to the second pulse is much smaller than the single pulse rise for the first pulse, because of the non-linear $\Delta T_e(P)$ dependence in Fig. 3a. This results in a greatly diminished integrated JNP signal around $t_d$ ~0 ps. Figure 4a shows the normalized JNP as a function of $t_d$. JNP$(t_d)/$JNP$(120$ ps).

The curves follow an inverse exponential form where the half-width at half-maximum (HWHM) of the central dip defines $\tau$, which is in very good agreement with previous studies. As $G_e$ at low $T_e$ is dominated by WF, $\tau$ is on the order of only ~30 ps, which is much faster than one would expect in e–ph limited device architectures.

From the above device characterization, we can define the bolometer’s performance characteristics, the noise equivalent power (NEP) and the intrinsic reset time, which is defined by $\tau$.
Fig. 4 | Detector performance. a. Normalized JNP($t_\text{m}$)/JNP(120 ps) probed with two $t_\text{m}$ time-delayed laser pulses at various device temperatures $T_\text{m}$ and at $V_\text{bg}=0$ V (graphs are offset for clarity). From the HWHM of the dip around at $t_\text{m}=0$ ps we extract the intrinsic thermal relaxation time of the bolometer $\tau$. As $G_{\text{th}}$ becomes reduced at low $T$, $\tau$ in turn increases. b. NEP and $\tau$ as a function of $T_\text{m}$ at $\Delta V_\text{bg}=0$ V. We extract a NEP $\sim100$ pW Hz$^{-1/2}$ and an intrinsic reset time of $\tau\sim30$ ps at $T_\text{m}=5$ K, the bolometer has a unique combination of high readout sensitivity and high intrinsic bandwidth. It has no hard limit on the operation temperature.

(Fig. 4b). Here the calibration of the bolometric readout scheme gives an overall sensitivity of $\Delta T_\text{m} \sim10$ mK for a measurement time of $t_\text{m}=1$ s (Supplementary Information), which together with the $G_{\text{th}}$ values from Fig. 3b allows extraction of the NEP values of the bolometer. The bolometer has no hard limit on the operation temperature and can be operated above liquid nitrogen and even room temperatures, with typical values reaching a NEP $\sim10$ pW Hz$^{-1/2}$ and a $\tau\sim30$ ps at $T_\text{m}=5$ K and $\Delta V_\text{bg}=0$ V. At the CNP, the NEP is strongly reduced, while $\tau$ only weakly varies with $\Delta V_\text{bg}$ (refs 16–19). Generally, while the NEP is dramatically reduced at low $T$, $\tau$ is increased.

As is given by the Dicke radiometer relation$^{19}$, the temperature sensitivity of the system is given by $\Delta T=(T+T_\text{sys})/B(t_\text{m})^{1/2}$, where $B$ is the measurement bandwidth, $t_\text{m}$ the measurement time and $T_\text{sys}$ the system noise, which is dominated by the LNA (Supplementary Information). From this relation it is clear that the sensitivity can be dramatically reduced by cooling the entire measurement circuit, the use of quantum-limited amplifiers and by increasing $B$, and it was shown theoretically that the presented device concept could reach an NEP $\sim10^{-20}$ W Hz$^{-1/2}$ at $T=10$ mK (ref. 19). Given the ultrafast intrinsic bandwidth of the bolometer, its ultimate detection speed is mainly limited by the readout electronics. While state-of-the-art LNAs can operate at frequencies above 10 GHz, such a fast readout would dramatically lower $\Delta T_\text{m}$ (as follows from the Dicke relationship (Supplementary Information)). In this regard, a practical graphene bolometer design would have to operate at a carefully chosen trade-off space between the desired measurement sensitivity and a fast readout, which is captured by the value of the NEP. In addition, while the integration of the bolometer into resonant light structures will enhance light absorption, it will sacrifice graphene’s broadband absorption properties. It is, however, feasible that one could develop small bolometer arrays, similar to the recently developed microwave single-photon detector arrays, where each bolometer is individually coupled to a PCC with a different resonant frequency, making the array sensitive to a broad range of frequencies.

In conclusion, the presented study shows the promises and challenges towards practical applications of graphene-based bolometers. With its improved light absorption, high sensitivity, ultrafast thermal relaxation time, no limitations on its operation temperature and the potential for mid-infrared and THz applications, this proof-of-concept device provides unique characteristics for the development of advanced bolometers with new functionalities.

Methods

Methods, including statements of data availability and any associated accession codes and references, are available at https://doi.org/10.1038/s41565-018-0169-0.

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References


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**Competing interests**

The authors declare no competing interests.

**Additional information**

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Device fabrication. The hBN–graphene–hBN stacks were exfoliated and assembled using a van der Waals assembly technique and then transferred onto the PCC cavity. The total thickness of the two hBN layers is around 30 nm. We patterned the hBN–graphene–hBN stack with hydrogen-silsesquioxane (HSQ) resist and CHF$_3$ + O$_2$ plasma exposed the edges of graphene, which was subsequently contacted by Cr/Pd/Au (1/20/50 nm) metal leads using electron-beam evaporation. The L3 PCC cavities were fabricated on a silicon-on-insulator wafer using a series of electron-beam lithography, reactive ion etching and a wet-etch undercut of the insulator to produce free-standing membranes. The top silicon membrane has a thickness of ~220 nm with a PCC lattice period of $a = 440$ nm and an air hole radius $r = 0.29a$. A linear three-hole (L3) defect in the middle of the PCC lattice serves to form confined optical cavity modes.

Optical measurements. The devices were illuminated with a scanning cross-polarized confocal microscope set-up. The reflection from the cavity was collected and coupled to a spectrometer to analyse its spectrum. For time-resolved measurements we used laser pulses from an optical parametric oscillator (OPO) pump by a Ti:Sapphire mode-lock laser (Mira-HP, Coherent). The pulse duration is 250 fs with a repetition rate of 78 MHz.

Data availability. The data that support the findings of this study are available from the corresponding author upon reasonable request.